

application
accept of
330-99
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pan, et al.

Serial No.: To be assigned

Filed: February 26, 1999

**For: WELL-DRIVE ANNEAL TECHNIQUE
USING PREPLACEMENT OF NITRIDE
FILMS FOR ENHANCED FIELD
ISOLATION**

Examiner: To be assigned

Group Art Unit: To be assigned

Attorney Docket No.: 3027.1US(96-0684.1)

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL248175148U

Date of Deposit with USPS:February 26, 1999

Person making Deposit: Jared Turner

PETITION TO ACCEPT PHOTOGRAPHS AS DRAWINGS (37 C.F.R. § 1.84(b))

**Assistant Commissioner for Patents
Washington, D.C. 20231**

Siri

Petition is hereby made to accept photographs in this case. Three (3) sets of photographs are submitted herewith. The reason why photographs are necessary in this case is as follows:

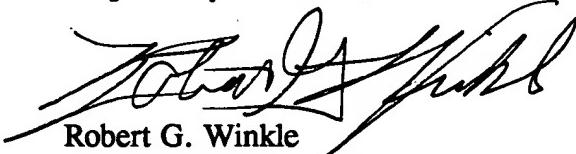
For clear illustration of the effects of the present invention, scanning electron micrographs have been taken of the semiconductor device with and without utilizing the present invention.

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Attorney Docket: 3027.1US(96-0684.1)

A check in the sum of \$130.00 is attached in payment of petition fee (37 C.F.R. § 1.17(i)). Please charge Account No. 20-1469 for any fee deficiency, or credit said Account for any overpayment.

Respectfully submitted,



Robert G. Winkle
Registration No. 37,474
Attorney for Applicants
TRASK, BRITT & ROSSA
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Telephone: (801) 532-1922

Date: February 26, 1999

RGW/kf

Enclosures: Three (3) sets of photographs
Check in the amount of \$130.00